

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	4	("5512131" "5900160").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2008/12/12 12:16
S2	28	(5,096,941 5,284,766 5,602,029 4,789,601 6,368,838 5,981,425 5,721,131 5,470,739 5,512,131 5,593,814 5,669,303 5,725,788 5,900,160 6,294,313).PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2008/12/12 12:23
S3	19	S2 and (light or radiate or irradiate or irradiation or radiation or photolithography or photoetching or photobleaching)	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2008/12/12 12:25
S4	12	S3 and (cell or tissue or culture)	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2008/12/12 12:26
S5	2	"20050089973".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2008/12/15 08:10
S6	2	("6582947").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/02/05 14:52
S7	24	(20020182633 20020095219 20030219889 20030089259 20040235167 20050186674 20050208656 20050255594 20050266319 20050279730 20060019390 20060183219).pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/02/05 14:55
S8	6	(7252923 6800405 6811945).pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/02/05 16:18
S9	2	"5130263".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/02/06 07:32

S10	5996	substrate near30 (cell near25 (adhesion or adhesive))	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/02/06 07:39
S11	107	S10 near30 (photoresist or photocatalyst or photocatalytic or titanium or zinc or tin or strontium or tungsten or bismuth or iron)	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/02/06 07:42
S12	0	("20020219889").pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:16
S13	0	"20020219889".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:16
S14	2	"20030219889".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:17
S15	2	"6800405".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:22
S16	6481	substrate near30 (cell near25 (adhesion or adhesive))	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:28
S17	116	S16 near30 (photoresist or photocatalyst or photocatalytic or titanium or zinc or tin or strontium or tungsten or bismuth or iron)	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:28
S18	15	S17 near30 (mask or photomask or lithography or photolithography)	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:29
S19	1	S18 and @ad<"20040326"	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:30
S20	428219	(substrate or solid or support or matrix or scaffold) near35 cell	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:32
S21	23586	S20 near35 culture	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:32
S22	60	S21 near35 (mask or photomask or lithography or photolithography)	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:32
S23	19	S22 and @ad<"20040326"	US-PGPUB; USPAT; EPO; JPO; DERWENT	ADJ	ON	2009/09/23 16:32

EAST Search History (Interference)

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